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Understanding noninvasive charge transfer doping of graphene: a comparative study

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Abstract

In this work, we systematically investigate and compare noninvasive doping of chemical vapor deposition graphene with three molecule dopants through spectroscopy and electrical conductivity techniques. Thionyl chloride shows the smallest improvement in conductivity with poor temporal and thermal stability and nitric acid induces the biggest sheet resistance reduction with modified stability. Molybdenum trioxide doping stands out, after thermal annealing, with both causing a significant sheet-resistance reduction and having superior temporal and thermal stability. These properties make it ideal for applications in advanced electronics. Theoretical studies based on the van der Waals density functional method suggest that cluster formation of molybdenum trioxide underpins the significant reduction in sheet resistance, and the stability, that arises after thermal annealing. Our comparative study clarifies charge transfer doping of graphene and brings understanding of the weak-interaction nature of such non-destructive doping of graphene. Our work also shows that we can use weak chemisorption to tailor the electronic properties of graphene, for example, to improve conductivity. This ability open up possibilities for further use of graphene in electronic interconnects, field effect transistors and other systems.

1 Introduction

Graphene is attractive due to its very high carrier mobility and current-carrying capacity. It is ideal for applications as transparent conductors, electronic interconnects, field effect transistors and more [1]. Graphene doping is being investigated as a viable technique to tailor its electronic properties

and improve conductivity. Doping of graphene through functionalization, via either thermal treatment or plasma treatment create many defects in the graphene, causing damage to the electronic structure and increased scattering and very difficult to control these processes. Surface-charge transfer based doping is also being investigated in various carbon materials [2–4]. It is important that the adsorption binding is not so strong that it then disrupt the graphene properties and not so weak that there is no thermal stability. However, some of these doping mechanisms also involve adhesion of organic species that are themselves large enough that they can be held firmly in place by van der Waals (or more generally nonlocal-correlation) [5] forces. Similarly, small molecules (that may by themselves desorb) may cluster, thus gaining a large physical extension that still permits it to be held in place by weak chemisorption. With weak chemisorption one will have a finite charge transfer but one will not have any significant graphene deformation [6, 7]. In effect, one achieves the analogy to modulation doping (known from semiconductor-hetero structure designs) and can thus suppress scattering.

For example, metal chlorides [8–12], organic dopants [13–17] and volatile oxidants (HCl, H₂SO₄, HNO₃, SOCl₂) have been studied in recent years as viable dopants for surface transfer doping of graphene [18–21]. Kasry et al. [22]

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studied the effect of p-type doping on graphene using nitric acid to reduce its sheet resistance to a value closer to conventional transparent conducting oxides. They observed a reduction in sheet resistance by a factor of 3 and yielded films consisting of eight stacked layers of graphene with a sheet resistance of 90 ohms/sq. and a transmittance of 80%. They attribute the reduction in sheet resistance to the formation of charge transfer complex between graphene and nitric acid described by the following reaction which was proposed by Fillaux et al. [23]. Das et al. [24] dip casted pristine graphene in HNO_3 solution of varying concentrations of HNO_3 . The work function was increased from 4.52 to 5.31 eV causing a shift in the Fermi level in graphene which gave it a p-type doped character with increased hole concentration. Bae et al. [25] used wet chemical doping using HNO_3 on 30-inch chemical vapor deposition (CVD) graphene made using a roll to roll process and obtained films with sheet resistance of about 125 ohms/sq. and an optical transmittance of 97.4%. They further improved these values to about 30 ohms/sq. with 90% transparency by making a doped four layer film using layer by layer stacking.

Eda et al. [26] demonstrated that SOCl_2 treatment reduced sheet resistance in graphene oxide films and used it as a transparent hole collecting electrode in organic photovoltaic devices. Li et al. [27] studied the effect of SOCl_2 doping of CVD graphene on photovoltaic properties of the graphene/silicon Schottky junction solar cell and found that it significantly improved the conductivity of graphene and improved the conversion efficiency of the cell by threefold. Later, two articles from the same laboratory investigated several dopants for applications in graphene/silicon hetero junction solar cells [28, 29]. The first article demonstrated p-type chemical doping using chloride and nitrate ions from SOCl_2 and HNO_3 respectively to enhance the Schottky junction in the solar cells [28]. They found that nitrate ions were better at reducing the sheet resistance and increasing the work-function for better charge separation and transport leading to an improvement in efficiency by a factor of 1.68. The second article explored the effect of doping via four volatile oxidants namely, HCl , HNO_3 , H_2O_2 and SOCl_2 on the power conversion efficiency (PCE) of graphene/silicon solar cells and this study also evaluated the thermal stability [29]. They found that all of them showed an improvement in PCE with SOCl_2 showing the best out of them. PCE was found to be decreased with time and SOCl_2 and HCl cases showed better stability than the rest.

There are contrasting observation reported for HNO_3 and SOCl_2 doping case. Cui et al. [29] reported that SOCl_2 doped Graphene/Si Schottky heterojunction solar cells shows better power conversion stability than HNO_3 doped case. However, Li et al., [28] demonstrated that nitrate ions from HNO_3 were found to be more effective for reducing the sheet resistance and enlarging the work function

of graphene for effective charge separation and transport compared to SOCl_2 case. Meanwhile, Chen et al. [30] and Xie et al. [31] demonstrated effective and non-destructive p-type doping of epitaxial graphene by depositing thin films of MoO_3 on its surface. Their results show that the large difference in work function between the epitaxial graphene (4.0–4.3 eV) and MoO_3 (6.8 eV).

In case of MoO_3 different doping mechanisms are reported. Some papers discuss charger-transfer induced due to annealing [32] and some discuss MoO_3 cluster formation due to multistage doping, without annealing [33–37]. Formation of metal carbide (Mo-C) with annealing at very high temperature is also reported [38]. Wu et al. [39] conducted a similar electronic structure study of interface between MoO_3 and CVD graphene and observed a hole density of about $5.44 \times 10^{12} \text{ cm}^{-2}$ and a lowering of Fermi level by 0.28 eV. They report that the formation of surface negative dipoles due to electron transfer from the graphene to MoO_3 causes an increase in the samples work function and the presence of gap states due to oxygen vacancies significantly reduces the hole injection barrier at the interface. Hellstrom et al. [32] demonstrated strong and stable doping of graphene and CNT films using MoO_3 for transparent electrodes. They observe a reduction in sheet resistance after the interaction with the MoO_3 , and also observed that the sheet resistance further reduced upon annealing these systems in an inert gas atmosphere. In their experiments with graphene MoO_3 bilayers, they observed a reduction of sheet resistance from 465 ohms/sq. to 340 per square. which was further reduced to 260 ohms/sq. 24 h after annealing with an overall improvement by 42%. Hellstrom et al. [32] have also demonstrated doping stability, noting that the sheet reduction of the conductivity was observed upon high temperature annealing. They claimed that the annealing drives the partial oxidation of the nano carbon and partial reduction of MoO_3 much further than mere deposition and refer to it as activation of MoO_3 towards chemical oxidation of nanocarbon which they found to be optimal around 450 °C. Quite recently, Meyer et al. [33] studied the interface structure of graphene with thermally evaporated MoO_3 films and found that it gave rise to large 1.9 eV interface dipoles and a downward bending of the MoO_3 conduction band towards the Fermi level of graphene causing a nearly ideal alignment of the transport levels. The Fermi level shifted downwards by 0.25 eV manifesting as a p-type doping with sheet resistance values lower than 50 ohms/sq. for few layer graphene. Santiago et al. [40] reported a two order improvement of electrical properties carbon nano tubes after evaporation with MoO_3 . There is no annealing effect in these carbon nanotubes- MoO_3 systems; merely changing thickness gave rise to improve the electrical conductivity. It is therefore interesting to determine if different oxidation states on MoO_x are created [7] due to the formation of MoO_x clusters.

The current work seeks and tests techniques that can effectively dope the graphene while causing minimal to no damage to the graphene structure. This is necessary for its application in advanced electronics but we have found no other comparative studies of non-destructive charge transfer doping of graphene using three kinds of dopants thionyl chloride (SOCl_2), nitric acid (HNO_3) and molybdenum trioxide (MoO_3) in the literature. Our work has the following key objectives: (i) establish protocols for non-destructively doping graphene using charge transfer doping to improve its conductivity for application in electronics; and (ii) determine the most effective doping scenario for applications in advanced electronics by comparing the merits of using SOCl_2 , HNO_3 and MoO_3 as p-type dopants for graphene. Finally, we comment on the most effective doping scenario for applications in advanced electronics by comparing their merits.

2 Experimental section

2.1 Methods: synthesis of graphene, chemical doping and theoretical studies

The graphene was grown using a thermal CVD process with copper as the catalyst. Copper foil was used as the growth substrate which was first cleaned and then subjected to high temperatures in a thermal CVD setup in the presence of a carbon source to result in graphene growth. Three kinds of dopants SOCl_2 , HNO_3 and MoO_3 were used for chemical doping experiment. All reagents were received from Sigma-Aldrich and used as-received without further purification. More details about the thermal CVD process and chemical doping are given at Supporting Information section.

Our theoretical analysis is based on first-principle density functional theory (DFT), using the van der Waals density functional (vdW-DF) method [41–43]. We use the consistent-exchange vdW-DF-cx version [44] as implemented in the Quantum Espresso (QE) code package [45]. We determine the adsorption-induced doping by computing the charge distribution on each atom using Bader analysis [46]. We also perform Car–Parrinello molecular dynamics (CPMD) simulations [47], again using QE package, to track the stability of binding and cluster formulation.

The graphene is modelled by a 5×5 unit cell containing 50 atoms and a vacuum region of at least 12 \AA . Ultrasoft pseudopotential with a cutoff energy of 40 Ry and a $4 \times 4 \times 4$ Monkhorst-Pack k-point sampling is used in our DFT simulations. All atoms are allowed to move till the interatomic forces are smaller than 0.008 eV/\AA .

For all of the CPMD simulations the Brillouin zone integration is performed using the Gamma-point only. The equation of motion is integrated using a timestep of 8 a.u.

and an electron mass of 400 a.u. All adsorption systems are heated up to 350 K in canonical (NVT) ensembles with Nosé–Hoover thermostats. The stability of the adsorption systems is then studied in microcanonical (NVE) ensembles.

2.2 Characterization

Raman spectroscopy was carried out on the graphene samples before and after the doping process. A Raman microscope with a 638 nm laser along with a 1200 lines/mm grating was used for all measurements. The morphology of graphene was characterized by scanning electron microscopy (SEM). This process was carried out in a Zeiss Supra 60 VP instrument. X-ray photoelectron spectroscopy (XPS) was used to measure the composition, chemical and electronic states of the graphene samples before and after the doping process. Sheet resistance measurement was carried out in a 4-point probe setup (CMT-SR2000N). Temporal and temperature stability study of the doped graphene as a function of time was evaluated by measuring the sheet resistance of the doped samples over an extended period.

3 Results and discussion

In present study, CVD graphene has been non-destructively doped using a surface-charge transfer method to improve its conductivity for application in electronics. The efficacy of three kinds of dopants SOCl_2 , HNO_3 and MoO_3 were evaluated with respect to the extent of improvement in the conductivity of graphene, effect on the graphene quality and most importantly, their stability with increasing time and temperature. The latter criteria is essential to determine the viability of their use in electronic applications. So, we comment on the most effective doping scenario for applications in advanced electronics by comparing their merits after careful evaluation.

The graphene samples were grown using thermal CVD on the copper foil, its morphology was observed using SEM. Details of the synthesis and transfer were given at the Supplementary Information section (Supplementary Figs. 1–5). Raman spectroscopy was performed on the transferred graphene samples to check the quality of the transferred graphene and indicate that the graphene obtained is predominantly single layer. Raman spectrum of one of the transferred graphene samples along with a map of ratios between the 2D and G peak intensities showed at Supplementary Fig. 6. The D band around 1340 cm^{-1} indicates the level of disorder or defects in the graphene. A perfect crystal of graphene would not have a D band. As seen from the figure, the D peak is quite low and shows that the graphene obtained is of good quality. The two most prominent features expected in graphene, the G and the 2D bands are also visible. The G

band around 1601 cm^{-1} arises due to the in-plane stretching of carbon–carbon bonds and is a signature for all carbon allotropes with sp^2 bonding. The most intense feature is the 2D band around 2645 cm^{-1} and is the second order of the D peak. The ratio between the 2D and G peak intensities (I_{2D}/I_G) are above 1 in all cases and most of them are close to or above 2. This ratio above 1, along with the narrow FWHM of the 2D band close to 30 cm^{-1} indicate that the graphene obtained is predominantly a single layer and verify the observations using SEM. It is worth mentioning that although the same process was used to prepare the graphene samples, there was some degree of variation in the quality of graphene obtained and the Raman spectra between samples. Therefore, each sample was analyzed individually before and after doping.

After the graphene samples were synthesized, they were doped with three kinds of dopants SOCl_2 , HNO_3 and MoO_3 , and analyzed to observe the effect of doping through various characterization techniques. The details of the doping were given at method section and supplementary information section. The morphology of the graphene films after the different doping treatments were observed using SEM. Figure 1a, b and c, d show SEM images of graphene samples after the SOCl_2 and HNO_3 treatment respectively. The graphene flakes and grain boundaries are visible. An organic substance was observed after the graphene was exposed to vapors. The wrinkles that were observed in the untreated graphene seem to have reduced after the vapor treatment process in both the cases. There were no major rips or tears observed in the films for either of the cases showing that the process of vapor doping is not strong enough to cause major tears to the graphene as in other chemically converted graphene. The morphology of graphene after MoO_3 deposition is showed at Fig. 1e, f. The MoO_3 seems to have covered all of the graphene while the grain boundaries and wrinkles of the graphene underneath are still visible. It also appears that the MoO_3 deposition is slightly more aggregated near the wrinkles and is more visible. SEM images of the sample after annealing have been shown in Fig. 1g–i. At a lower magnification, the graphene does not look much different compared to the undoped graphene. However, on closer examination the MoO_3 has formed smaller islands which uniformly cover the underlying graphene. This was not observed in the samples after deposition and indicates that the MoO_3 undergoes dewetting from the graphene film during the annealing.

Sheet resistance for the samples was measured for three samples before and after doping for each dopant species. The sheet resistance values before and after SOCl_2 treatment in three different samples that have been numbered for convenience (Fig. 2a). It can be seen that a reduction in sheet resistance is consistently observed in all three samples. Sample 1.1 shows the biggest reduction of 41% while the smallest

reduction is 37% in sample 1.3. The average reduction in sheet resistance from these three samples is about 38%. Figure 2b highlights the effects found in the case of HNO_3 treatment. Here there is a significant reduction in sheet resistance consistently observed with the biggest reduction of 73% and an average reduction of about 70% which is significantly more than the SOCl_2 case. Figure 2c shows the comparison between sheet resistance values for three samples before MoO_3 deposition, after deposition and after annealing. It can be seen that for all three samples, the sheet resistance values initially increase after deposition. This is probably because the graphene materials are not coated with MoO_3 immediately after they are transferred so they could be slightly degraded or contaminated when exposed in air. This is verified by experiment results that shows the graphene resistance change with different storage duration, as shown in Fig. S11 in the Supporting Information. However, the sheet resistance values reduce significantly after annealing at $450\text{ }^\circ\text{C}$ in argon atmosphere.

The previous reports on graphene doping with MoO_3 all report a reduction in sheet resistance soon after the deposition, while Hellstrom et al. [32] reported a more significant reduction after annealing. A reduction in sheet resistance was not observed immediately in any of the samples and was only observed after the annealing process. The annealing process possibly helped improve the interaction between the graphene and the MoO_3 causing the charge transfer and thus the reduction in sheet resistance. The biggest reduction in sheet resistance was 59% while the remaining two samples showed a reduction in sheet resistance by about 49% with an average reduction of about 52%. This variation in the extent of reduction in sheet resistance between the samples despite the same doping process could be due to the variation in the initial quality of the graphene and possibly some minor changes during the processing.

Raman spectroscopy was carried out on the graphene samples before and after the doping process to see the effect of doping on the graphene through changes in the spectra. Raman data obtained from the samples with the highest improvements (for each of the three doping candidates) are shown in the figures in this section. Figure 3a, b shows the Raman spectra of the samples before and after the SOCl_2 where the Fig. 3b shows the G band of the same spectra. One of the prominent features of p-type doping in graphene is an upshift of the G band. This can be clearly observed in this sample where the peak position shifts from 1599 cm^{-1} before doping to 1606 cm^{-1} showing an upshift by 7 cm^{-1} . This shift in the G band is an indication of p-type doping and is known to depend on the amount of charge removed per carbon atom. We note that greater shift implies more charge is withdrawn, although this dependence is not linear. This prominent shift in G peak was observed in all the samples. A reduction in I_{2D}/I_G ratio was observed along with

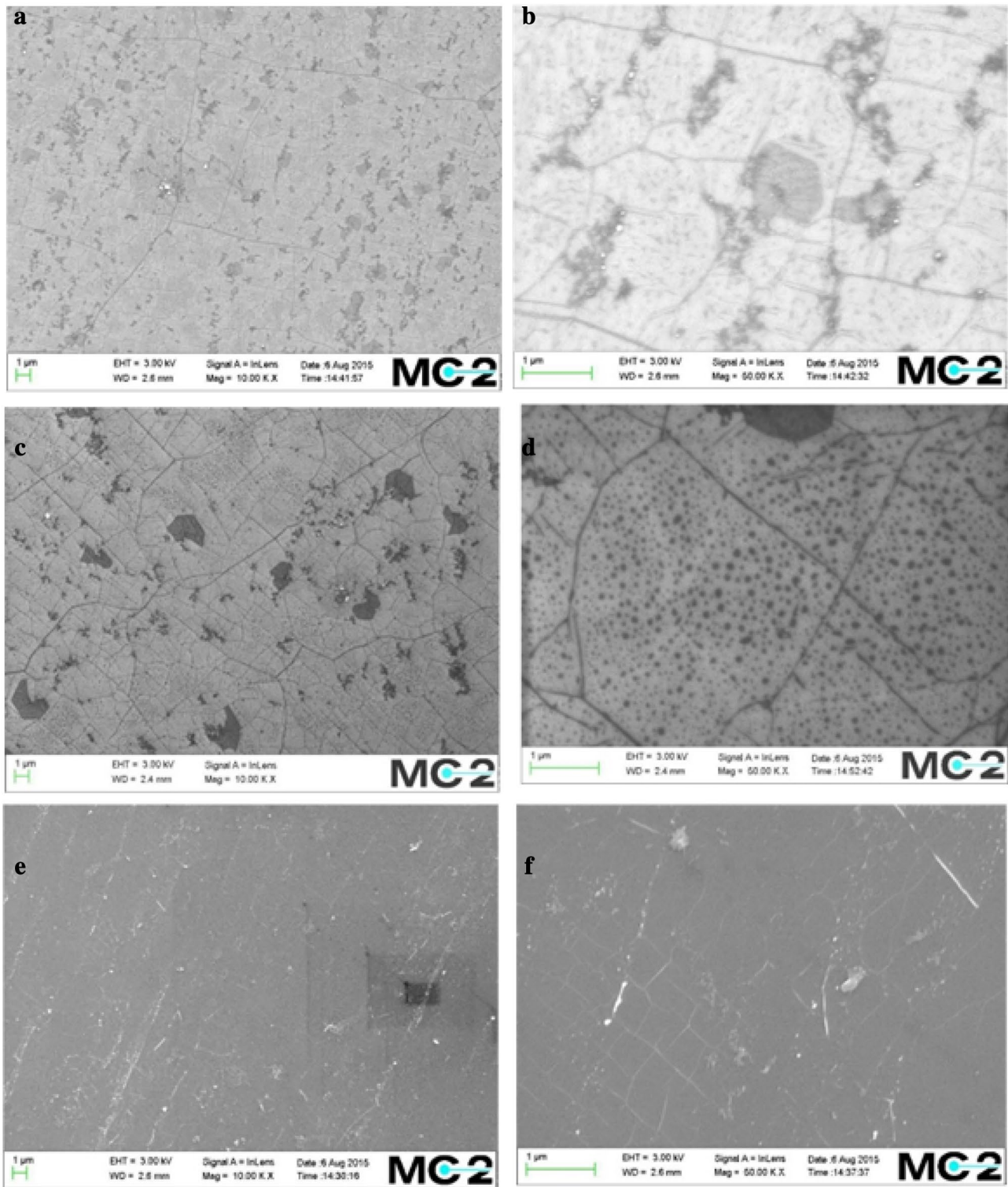


Fig. 1 SEM images of graphene treated with three different dopants with different magnification; SOCl_2 vapors (**a** 10 kx and **b** 50 kx) ; treated with HNO_3 vapors (**c** 10 kx and **d** 50 kx); after MoO_3 deposi-

tion (**e** 10 kx and **f** 50 kx); after MoO_3 deposition and annealing (**g** 10 kx **h** 50 kx **i** 150 kx)

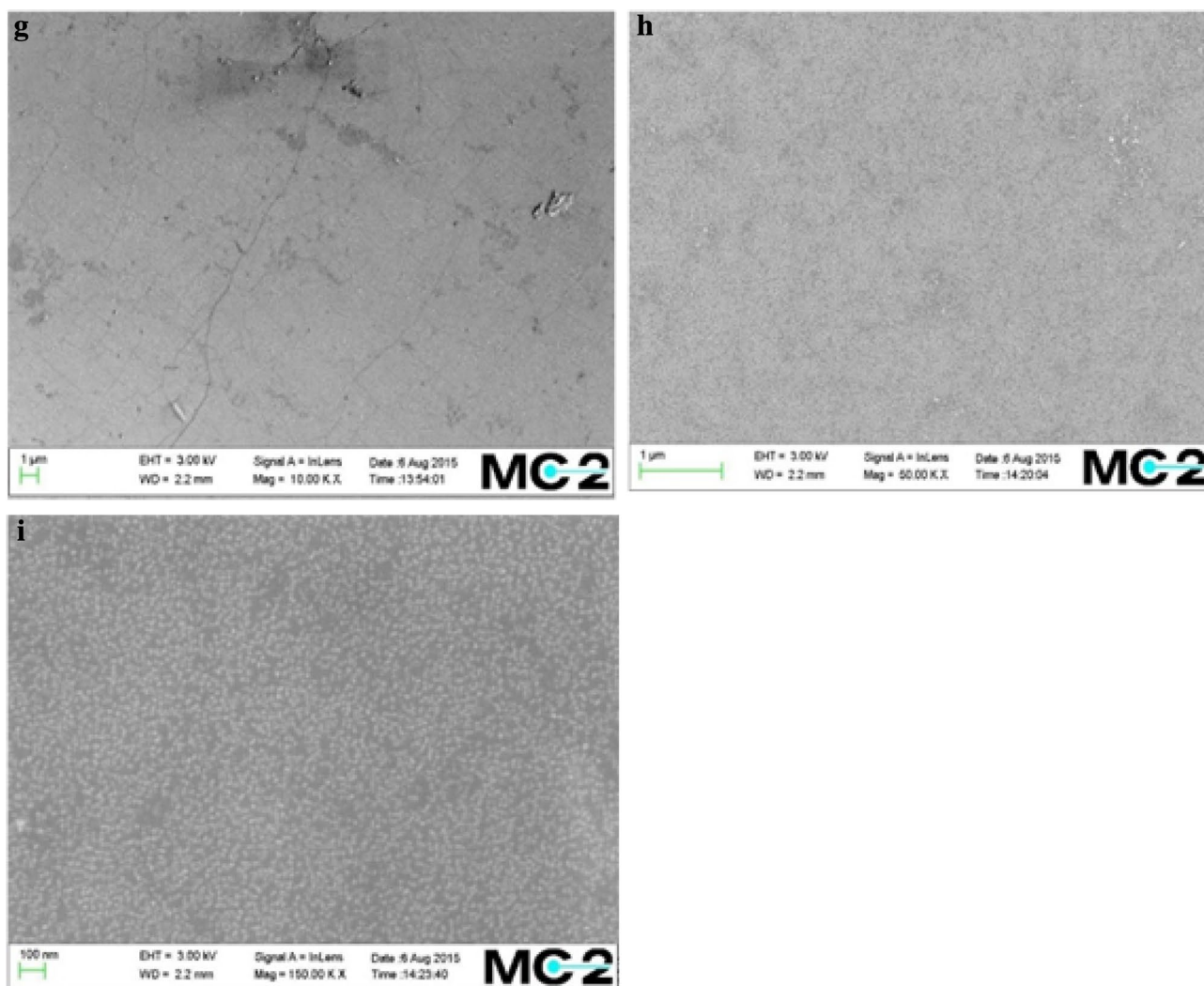


Fig. 1 (continued)

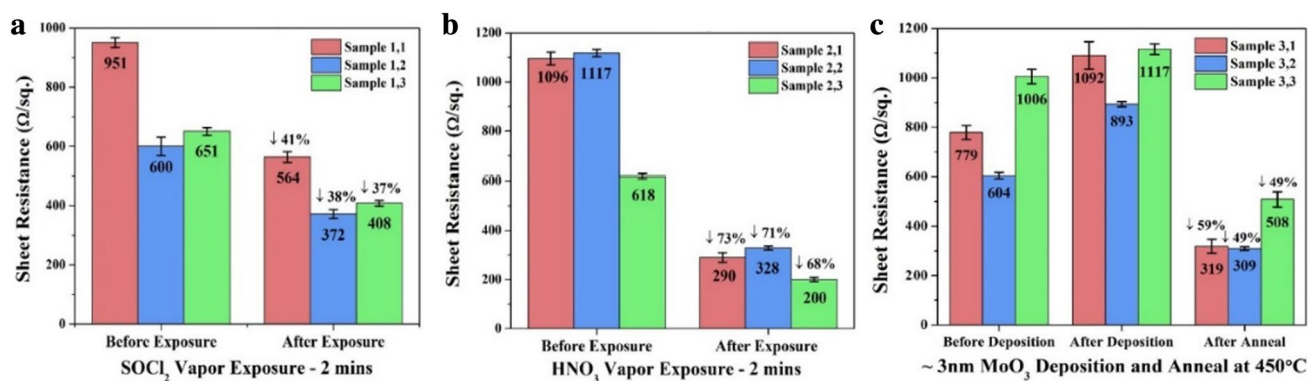
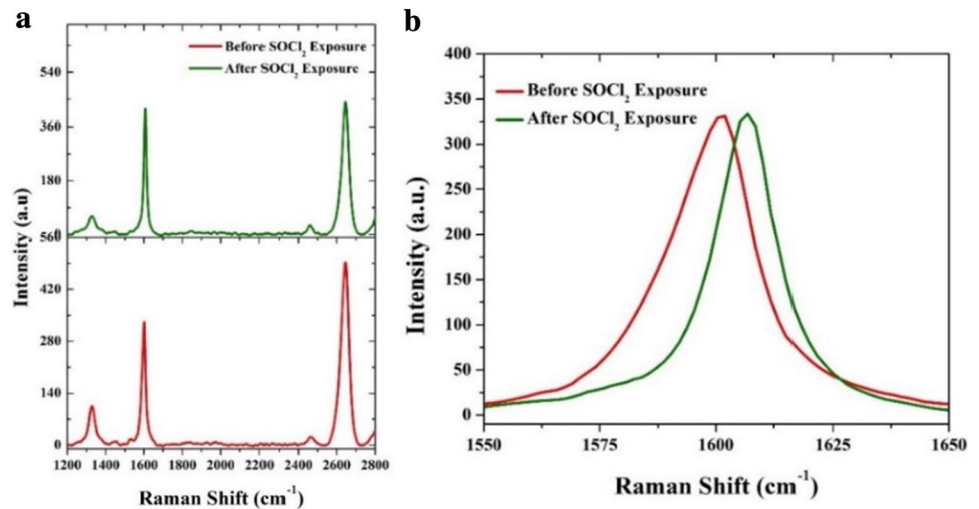


Fig. 2 Figure showing the change in sheet resistance of graphene sample after doping. **a** SOCl₂, **b** HNO₃, and **c** MoO₃. In case of SOCl₂ and HNO₃ sheet resistance values reduce after exposure, how-

ever in case of MoO₃, the sheet resistance values are increased after deposition and reduced significantly after annealing at 450 °C in argon atmosphere. (Color figure online)

Fig. 3 Raman spectra of graphene sample before and after SOCl_2 treatment: **a** full spectra, **b** G band region. (Color figure online)



a narrowing of the G band as can be seen from the Raman spectra which is expected from doping graphene due to suppression of the 2D band. Interestingly, it was observed that the ID/IG ratio reduced from 0.32 to 0.14 after the SOCl_2 treatment which corresponds to fewer defects in the graphene. This reduction was also observed to varying degrees in the other samples treated with SOCl_2 which suggests that the treatment reduces defects in the graphene and confirms its non-destructive nature.

Figure 4 compares the Raman spectra of the sample before and after HNO_3 treatment. In this case, the upshift in the G band position is even more pronounced where it shifts from 1601 to 1610 cm^{-1} with an increase of about 9 cm^{-1} . A similar upshift was observed in the other samples treated with HNO_3 and was always larger than that observed in the SOCl_2 treated samples. Therefore more significant charge transfer effect takes place in this case and agrees with the extent of reduction in sheet resistance when comparing both the vapor doping scenarios. There

was no major changes in the ID/IG ratio which suggests that the HNO_3 treatment does not introduce significant defects in the graphene. Figure 5 shows the Raman spectra of a graphene sample before MoO_3 deposition, after deposition and after annealing. It can be seen that although there is a minor upshift of the G band after the deposition from 1604 to 1605 cm^{-1} , the major shift by 15–1619 cm^{-1} was observed after annealing indicating that the charge transfer takes place during annealing and agrees with the results of the sheet resistance measurements. Another interesting feature is the broadening of the G band and a second component seems to exist in the G band after annealing. The origin of this second component is unclear and is associated with either deposition or adsorption of some material on the graphene, strain in graphene or presence of local charge inhomogeneity. A reduction of the I2D/IG ratio was also observed which is expected. There seems to be an increase in the ID/IG which suggests a slight increase in the defects in the graphene. However,

Fig. 4 Raman spectra of graphene sample before and after HNO_3 treatment: **a** full spectra, **b** G band region. (Color figure online)

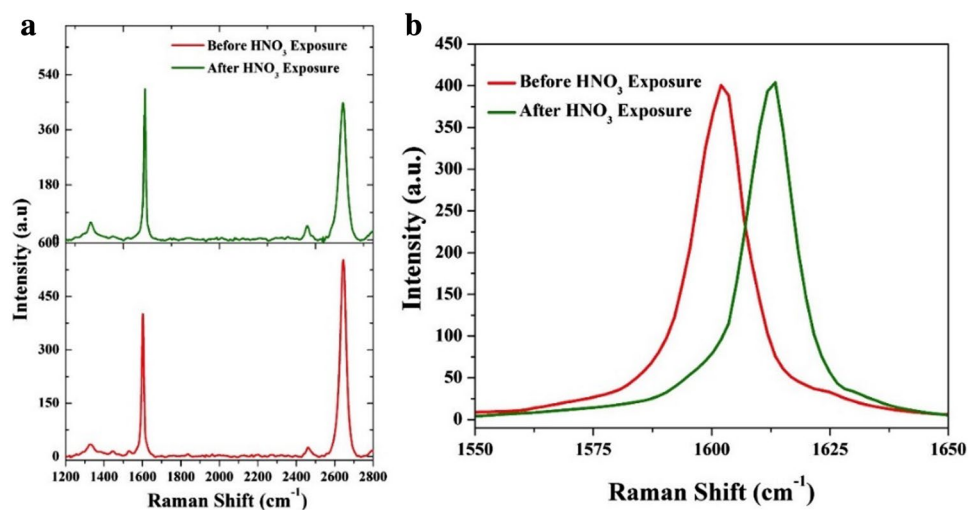
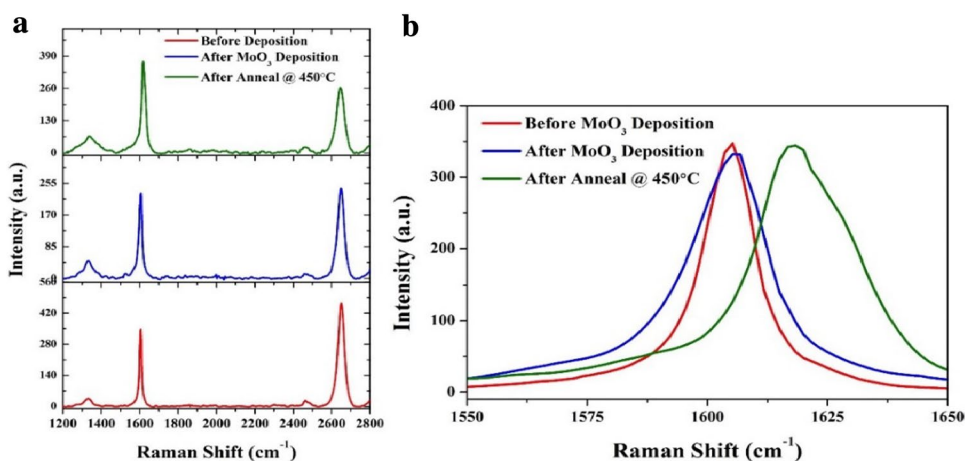


Fig. 5 Raman spectra of graphene sample before and after MoO₃ deposition and annealing: **a** full spectra, **b** G band region. (Color figure online)



this was not observed in all the samples and would require further investigation.

X-ray photoelectron spectroscopy also used to confirm the presence of the dopant species and to observe their interaction. The XPS also allowed us to track shifts in the Fermi level of graphene. We studied XPS obtained from four different samples; undoped graphene, SOCl₂ treated graphene, HNO₃ treated graphene, MoO₃ coated and annealed graphene. Precise quantification of the XPS spectra allows us to obtain composition but this approach also requires very exact fitting of the peaks with proper constraints. Survey spectra obtained from each of our four samples are given at Fig. 6. The predominant peaks have been labeled and the respective elements that would be expected were observed in each of the cases. Carbon, oxygen, and silicon peaks were observed in all the samples from the graphene and the underlying SiO₂ substrate. Moreover, The C1s and Cl2p peaks were visible in the sample treated with SOCl₂ vapors while N1s peak was detected in the sample treated with HNO₃ vapors. The sample doped with MoO₃ shows the Mo3s, Mo3p and Mo3d peaks. Apart from the expected peaks, there were also strong unexpected peaks such as the fluorine and aluminum peaks which appear on all the samples the origin of which is unclear. A high resolution C1s spectra were acquired for each of the sample.

The doped samples show varying degrees of shift when compared to the pristine sample (Fig. 7). The C1s binding energy for the undoped sample is about 284.69 eV, while that of the SOCl₂ has downshifted by 0.40–284.29 eV. In the case of the sample doped with MoO₃, the binding energy of C1s is centered around 284.40 eV showing a shift of 0.29 eV. However, a very small shift of 0.02 eV for HNO₃ doped sample was observed which is much smaller than expected. Therefore, the XPS measurements would need to be repeated and fitted carefully to extract precise changes in Fermi level of the graphene after doping. A high resolution spectra of Cl2p, N1s and Mo3d levels acquired from the

samples doped with SOCl₂, HNO₃ and MoO₃ respectively (Fig. 8). The Cl2p peak around 199 eV seems to consist two peaks, one near 198.5 eV which corresponds to the presence of Cl⁻¹ ions while the other around 200.3 eV which corresponds to Cl–C covalent bonds. The N1s spectra from the HNO₃ doped sample shows two main peaks, a large peak at 407.2 eV corresponding to C–N covalent bonding and another one around 400 eV which corresponds to the NO₃⁻¹ ionic bonds. These results suggest that the C–Cl and C–N interactions take place due to the doping process and contribute to the enhancement in the electronic transport [24, 28, 48]. The Mo-3d peak seems to consist of three main peaks. The peaks around 232.6 and 235.8 eV correspond mainly to Mo⁶⁺ oxidation states and possibly contain smaller components from Mo⁵⁺. The peak around 229.8 eV corresponds to the Mo⁴⁺ oxidation states. Previous works on doping of graphene with MoO₃ where the samples were not subjected to annealing did not show any peak corresponding to Mo⁴⁺ oxidation states [30, 32, 33]. These Mo⁴⁺ oxidation states seem to become visible only after the annealing which strongly suggests reduction of MoO₃, indicating that it receives electrons from the graphene, thus causing more efficient charge transfer. These results agree with the observation by Hellstrom et al. [32]. Moreover, no major evidence of Mo–C bonding was observed from the Mo3d spectra.

The temporal and temperature stability of the doped graphene as a function of time was evaluated by measuring the sheet resistance of the doped samples over an extended period. The results for the doping stability over time are reported at Fig. 9. We find that samples treated with SOCl₂ show the least stability with time. In fact it quickly reaches 99.6% of the initial sheet resistance value before doping. HNO₃ also shows a poor short term stability: while the initial reduction in sheet resistance is large, it goes up to 56.8% of the undoped value in just 2 days. However, thereafter it remains fairly stable beyond that reaching 66.3% of the undoped value at the end of 4 weeks. The increase in

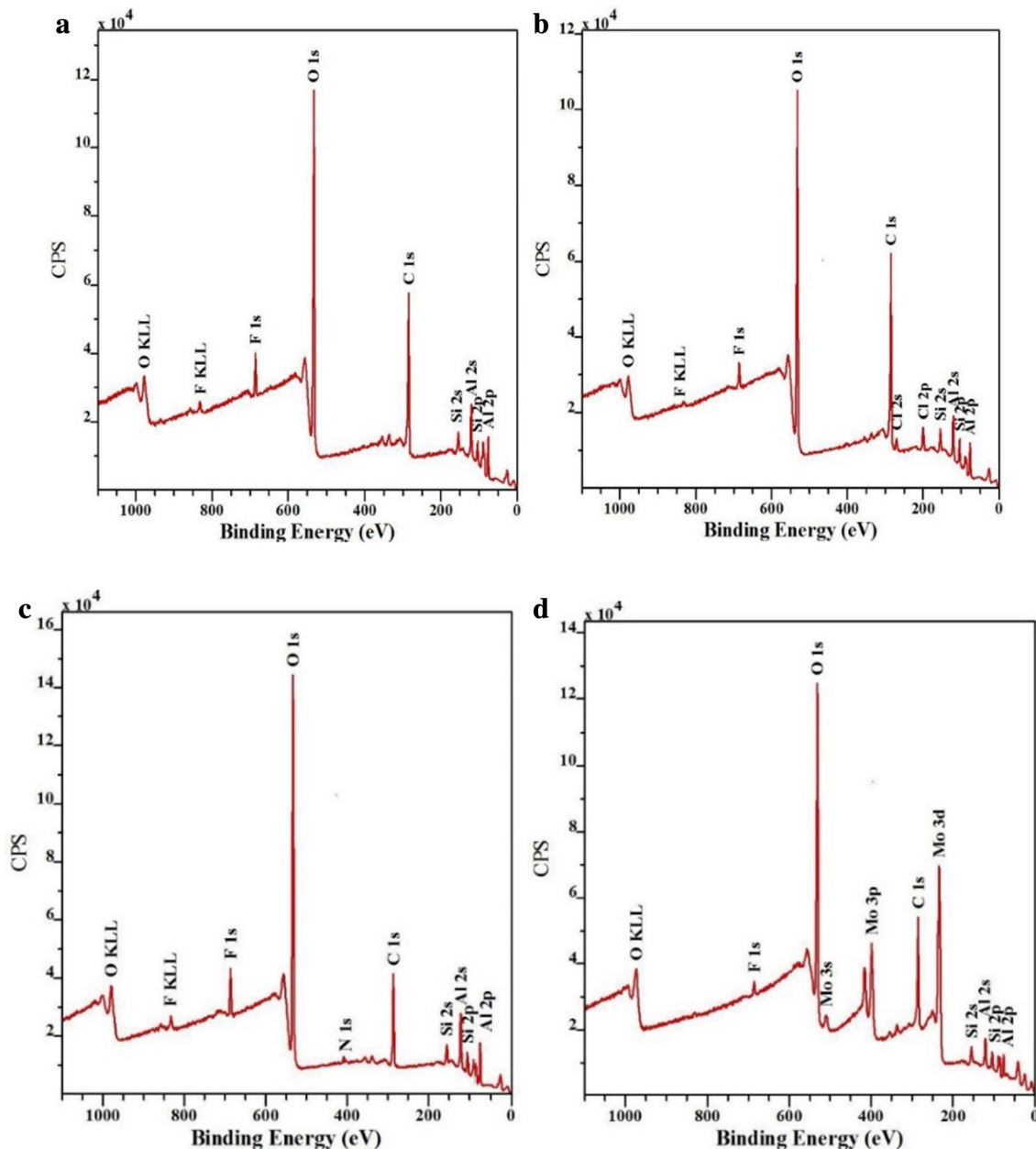


Fig. 6 The XPS survey spectra of pristine graphene and after doping. **a** Pristine, **b** SOCl_2 , **c** HNO_3 and **d** MoO_3

sheet resistance with time is possibly due to reaction with the moisture in the air and also desorption of the dopants from the graphene to some extent. This could be reduced by adding a protective layer on top of the graphene after doping, however it would lead to other complications during patterning and depositing contacts for electronic applications.

The sample doped with MoO_3 shows fairly good stability with time where the sheet resistance increases gradually to 63% of the undoped value at the end of 4 weeks and 66% at the end of 6 weeks. In this case, the increase in sheet resistance is predominantly due to the effect of moisture in the atmosphere. It is worth mentioning that some of the increase

in sheet resistance may be due to the damage caused by the probes during each measurement which is why the measurement was not carried out very often. This possible damage due to the probes could be avoided by depositing metal contacts on the graphene instead of using the probes directly on the graphene.

Figure 10 shows a quantification of doping stability with temperature. We track the percentage increase in sheet resistance for different dopants with increasing temperatures. The figure reports the percentage increase in sheet resistance which is plotted as a function of temperature. The percentage increase in sheet resistance is

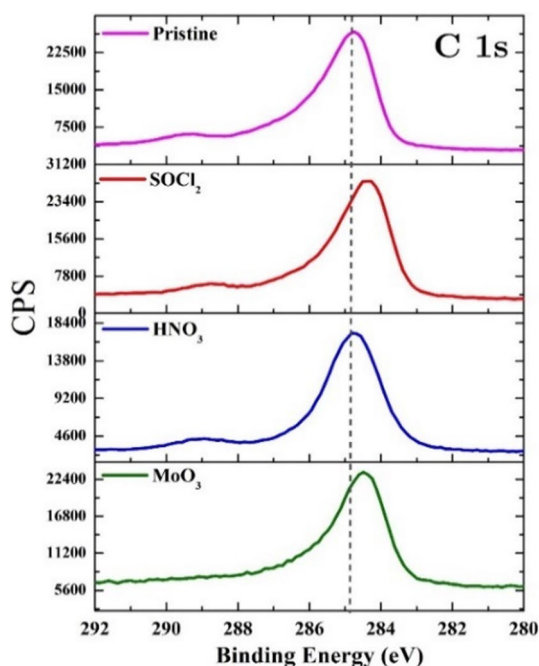


Fig. 7 High resolution XPS spectra of the four samples stacked for comparison. Top to bottom: Pristine, SOCl_2 , HNO_3 and MoO_3

much more pronounced for samples doped with HNO_3 and SOCl_2 than with MoO_3 . The SOCl_2 doped sample reached 43.2% of its initial doped value while HNO_3 doped sample reached around 40% at 200 °C. This increase in sheet resistance is attributed to desorption of the dopants from the graphene at elevated temperatures. It should be noted that although the percentage increase in both these cases is quite similar, the initial reduction in the case of HNO_3 is significantly larger and therefore the increase in the value of sheet resistance when compared to the undoped value is less significant than for the SOCl_2 doped sample. The effect of temperature on the sheet resistance is not very significant for the samples doped with MoO_3 where it reaches only 12.4% of the initial doped value. This shows

that the samples doped with MoO_3 has much better stability when compared to the other two doping scenarios.

3.1 Theoretical investigation

We also theoretically investigated the mechanisms of graphene doping by HNO_3 , SOCl_2 and MoO_3 molecules. Our focus was on understanding the charge transfer effects that follow the weak chemisorption of these molecules on graphene. First, we simulated the adsorption structures in DFT and tracked the stability using CPMD performed at 350 K.

Figure 11 reports the results of our CPMD simulations for HNO_3 on graphene. We find that there will be a dissociation of hydrogen or of hydrogen and oxygen atoms leaving NO_3 or NO_2 molecules to diffuse on the graphene. Below, we also document that the NO_x adsorption causes charge transfer, i.e., that the residual molecules are technically chemisorbed. However, the diffusion documented in the CPMD studies reflect a weak chemisorption nature for the NO_x -graphene system and we do, in fact, find limited adsorption energies (per molecule or molecular unit) in all of the cases. The adsorption energy is calculated from $E_{ads} = -(E^{gr+mol} - E^{gr} - E^{mol})$, where E^{gr+mol} is the adsorption system energy, E^{gr} and E^{mol} are the energy of isolated graphene and molecule. Regular chemical-bond formation does not account for behavior in the set of investigated adsorption cases and use of the vdW-DF method (instead of traditional semilocal DFT) is important for our theoretical characterizations.

Figure 12 summarizes our study of weak chemisorption of MoO_3 on graphene. In this study, we simulated the adsorption of a MoO_3 single molecule, a MoO_3 dimer as well as of three- and four-molecule clusters. Our CPMD simulations indicates that all $(\text{MoO}_3)_n$ adsorption structures are stable at 350 K. Our CPMD results from the four MoO_3 weak chemisorption problems further suggest that are significant clustering energies to drive formation of large adsorbate clusters and (at sufficient deposition) even assembly of MoO_3 coatings. Having identified optimal

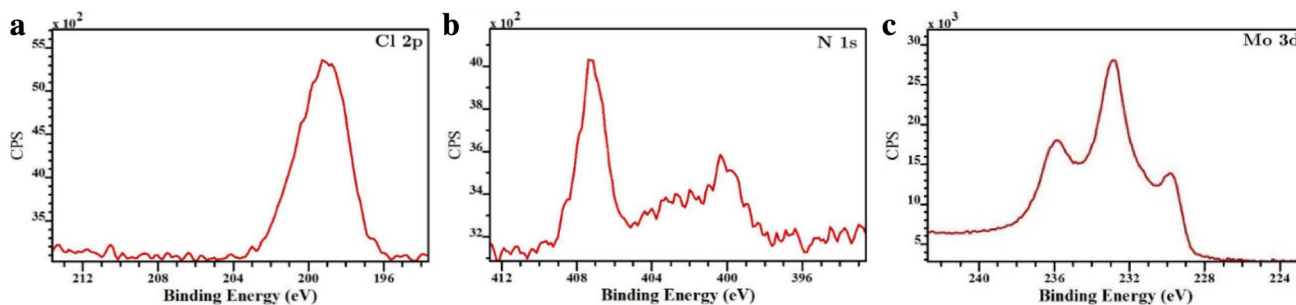


Fig. 8 High resolution XPS core level spectra for $\text{Cl}2p$, $\text{N}1s$ and $\text{Mo}3d$ obtained from samples doped with the respective dopant species. **a** $\text{Cl}2p$ - SOCl_2 treated, **b** $\text{N}1s$ - HNO_3 treated and **c** $\text{Mo}3d$ - MoO_3 deposition and annealing

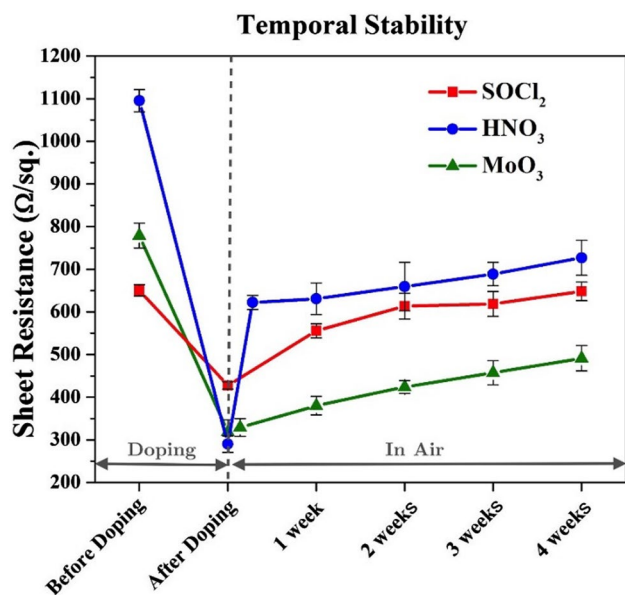


Fig. 9 Variation of sheet resistance with increasing time of the doped graphene samples

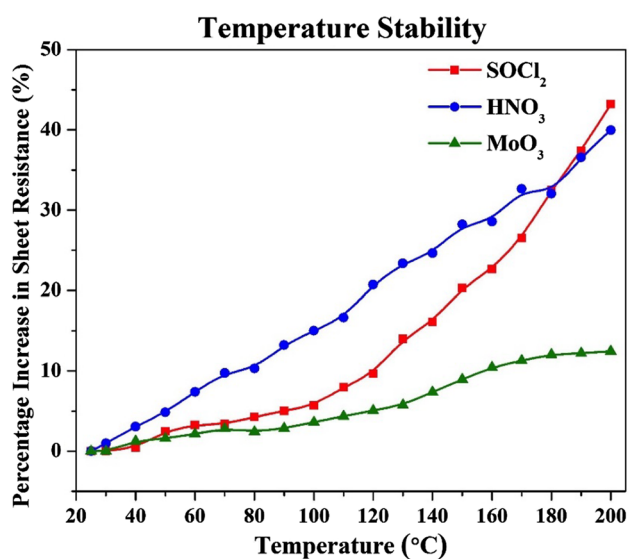


Fig. 10 Variation of sheet resistance with increasing temperature of the doped graphene samples

adsorption configurations, we extract total energies in the four systems and, in turn, define energy differences that characterize clustering among weakly chemisorbed MoO₃ on graphene. This clustering cohesive energy is calculated from $E_{cc} = -(E_{ads}^{gr+(MoO_3)_n} - nE_{ads}^{gr+MoO_3})/n$ and grows with the cluster size: it is 1.35 eV per molecule for a MoO₃ dimer, while it is 1.60 and 1.65 eV per molecule for (MoO₃)₃ and (MoO₃)₄ clusters.

The tendency for nucleation and assembly also explains why the thermal stability of the MoO₃ increases with thermal annealing: the MoO₃ clustering stabilizes the adhesion. Comparing the total energy of the adsorbed systems, of the clean graphene surfaces and of the molecule in the gas phase, we define adsorption energies E_{ads} . For larger adsorbates, weak chemisorption can easily provide binding in excess at the eV scale and beyond [5–7, 49]. Table 1 includes a comparison of the adhesion energy per molecules for the set of investigated dopants and dopant-cluster configurations. The table confirms that the MoO₃ cluster adhesion energy exceeds 1 eV already when reaching a three-molecular size.

Finally, our calculations permit us to track the doping and graphene modification that occurs at optimal adsorption configurations. Table 1 reports our vdW-DF-cx results for the adsorption distances, for the associated mean absolute displacement of the carbon atoms sitting immediately below the adsorbates, and for the resulting charge transfer (as asserted in a Bader analysis of the electron distribution in the optimal configurations).

Our calculations show that all three molecules can (p-) dope via weak chemisorption but also confirms that it is imperative to check stability. The HNO₃ adsorption causes dissociation and we have instead analyzed this strategy as a case of NO₂ and NO₃ weak chemisorption. Also, given the tendency for cluster nucleation, it is more important to characterize the doping impact of MoO₃ clusters instead of individual MoO₃ molecules.

Table 1 shows that p-doping efficiencies (as obtained in DFT) are in the order, SOCl₂ < (MoO₃)_n < NO₂/NO₃. The adsorption of SOCl₂ molecules does not seem to lead to any significant charge transfer. Given the anchoring of dissociated NO₃ and NO₂, one can expect that the addition of HNO₃ molecules produce the highest doping efficiencies. In addition, one should note that adding HNO₃ molecules also causes a strong chemisorption of excess hydrogen and oxygen atoms, shown in Fig. 11c, d, that further affects the scattering (and doping).

Interestingly, our calculations show that the assembly of MoO₃ clusters causes the doping nature to change: we predict a n-type doping for the (unstable) case of single-molecule adsorption while clustering converts the MoO₃ adsorption into p-doping agents. Given our documentation of a clustering driving force, our theoretical studies corroborate the finding that annealing plays a critical role in the MoO₃-induced (p-)doping.

In fact, our set of theory results seem fully consistent with the experimentally observed trends in conductivities, but we can only provide a qualitative discussion subject to an assumption of the original nature of conduction in the CVD-grown samples. In general, chemical doping increases the density of free (electron or hole) charge carriers by charge transfer mechanisms that modify the Fermi

Fig. 11 Results of molecular dynamics simulation of HNO_3 adsorbed and partly dissociated on graphene. Panel (a) shows the computed temporal evolution of the distances of the adsorbate atoms to the graphene layer. The HNO_3 molecules (b) dissociates to NO_3 (c) and then NO_2 (d) while the hydrogen and oxygen atoms disperse on the graphene. The various adsorbates states are indicated in panel (a). (Color figure online)

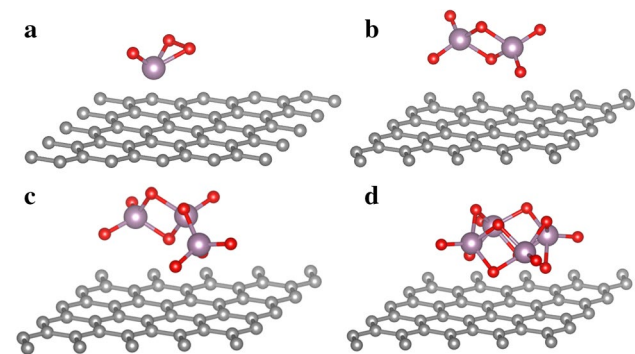
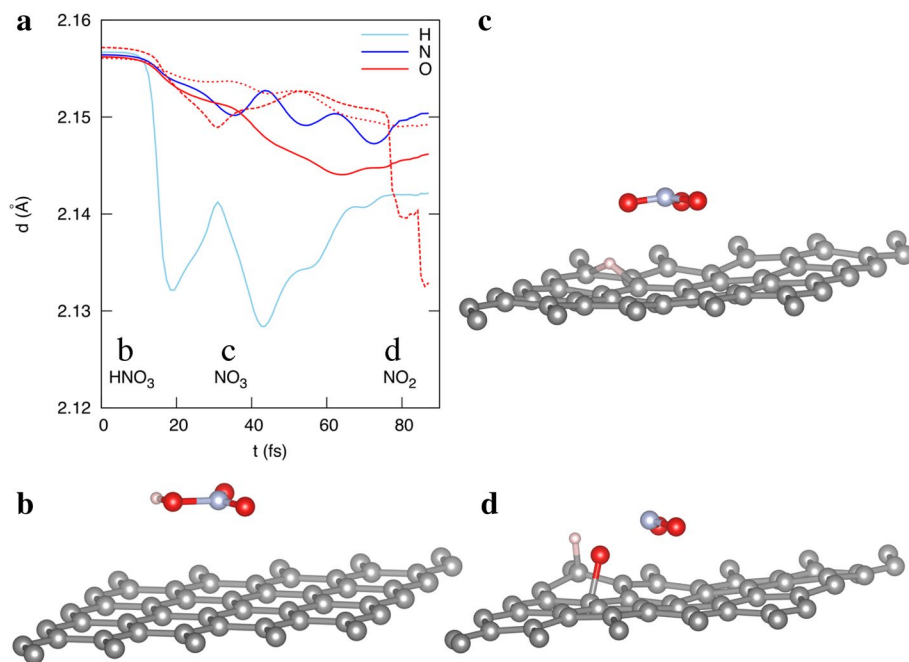


Fig. 12 Fully relaxed geometries in vdW-DF-cx of MoO_3 single molecule and the first few clusters on graphene

level of the doped. However, we do not know if the CVD-grown graphene samples were p or n doped from the outset and so we cannot trace the net impact that follows with predictions of the size of p-type doping. However, we can say this: if the samples was originally p-doped, the set of theory characterizations are consistent with the measured conductivity changes.

Subject to the stated assumption, the theoretical study does confirm the experimental observation that HNO_3 treatment gave rise to the highest resistance reduction but suffered from less stability. Overall, the theoretical characterization suggests that, with annealing and cluster assembly, MoO_3 holds advantages in terms of both thermal stability and by having a limited deformation at a fair charge transfer. However, the weak chemisorption of adsorption of MoO_3 clusters does cause some deformation

Table 1 Adsorption stabilities, configurations and doping efficiencies from first-principles simulations

Material system	E_{ads} (eV/molecule)	d (Å)	δz_C (Å)	Doping (e/molecule)
SOCl_2 -graphene	0.43	3.07	0.025	+0.02*
HNO_3 -graphene	0.29	3.22	0.020	+0.01
MoO_3 -graphene	1.40	2.46	0.031	-0.21
NO_3 -graphene		2.96	0.038	+0.51
NO_2 -graphene		3.42	0.013	+0.20*
$(\text{MoO}_3)_2$ -graphene	0.35	2.87	0.027	+0.14*
$(\text{MoO}_3)_3$ -graphene	0.36	2.82	0.026	+0.14*
$(\text{MoO}_3)_4$ -graphene	0.30	2.79	0.040	+0.12*

E_{ads} is the adsorption energy of the molecules on graphene. d is the vertical distance from the graphene plane to the closest atom. δz_C is the mean absolute displacement of the carbon atoms immediately under the adsorbates (measured from the graphene plane). The plus sign of doping corresponds to p-type doping while the minus sign corresponds to n-type doping. Stable adsorption configuration of each molecule is marked with asterisk

of the underlying graphene sheet, and it will induce electron scattering.

4 Conclusions

In summary, we demonstrate the efficacy of efficient, non-destructive doping of CVD graphene using thionyl chloride (SOCl_2), nitric acid (HNO_3) and molybdenum trioxide (MoO_3). The samples were characterized using microscopy, spectroscopy and electrical measurement techniques. The

samples doped with HNO_3 showed the largest (immediate) reduction in sheet resistance with an average reduction by about 70% and SOCl_2 treated samples on the other hand showed the smallest reduction in sheet resistance with an average reduction by 38%. Whereas MoO_3 deposition on graphene increased the sheet resistance initially, this was significantly reduced after the annealing process yielding an average reduction by about 52% compared to the undoped samples. Analysis of morphology using SEM showed no severe damage to the graphene from any of the doping processes. Raman spectra on the doped samples showed an upshift in the G band for all the cases confirming the transfer of electrons from the graphene to the dopants, increasing the density of holes at the interface, thus effectively giving the graphene a p-type doped character.

The presence of the dopant species on the graphene was confirmed using X-ray photoelectron spectroscopy and their interaction with the graphene was analyzed from their core level spectra. Samples doped with SOCl_2 showed the poorest temporal and thermal stability with both increasing time and temperature while samples doped with HNO_3 performed better in both the scenarios. MoO_3 doped samples showed the best stability with increasing time and temperature and seems to be the best candidate for applications in advanced electronics which require thermal stability. Our theory modeling results indicate the adsorption configurations of the three molecules are intact (SOCl_2), dissociated (NO_2) and clustered (MoO_3)_n. The p-type doping efficiencies are positively related to the resistance reduction in experiments and we have provided an interpretation of why annealing is essential when we seek to use MoO_3 as a (stable) p-type dopant for graphene. The results could be very useful for graphene based interconnects and transparent electrodes where the resistance is a key factor.

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